



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Masaaki HIROKI

Serial No. 10/810,646

Filed: March 29, 2004

For: DEVICE FOR INSPECTING

ELEMENT SUBSTRATES AND

METHOD OF INSPECTING

ELEMENT SUBSTRATES USING

ELECTROMAGNETIC WAVES

) Group Art Unit: 2829

) Examiner: V. Nguyen

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is
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) *Adrian M. Stamps*

)

AFTER FINAL AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated October 12, 2005, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.

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